



JTW

PATENT
Attorney Docket No. 4173.0362-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
TAKASHI ISHIGAMI)	Notice of Allowance Dated: 5/20/10
)	
Application No.: 10/732,888)	Group Art Unit: 2822
)	
Filed: December 10, 2003)	Examiner: R. Potter
)	
For: INTERCONNECTOR LINE OF)	Confirmation No.: 6183
THIN FILM, SPUTTER TARGET)	
FOR FORMING THE WIRING)	
FILM AND ELECTRONIC)	
COMPONENT USING THE)	
SAME)	

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENTS**

Applicant is in receipt of the Notice of Allowance and attached Notice of Allowability dated May 20, 2010.

Applicant filed an Information Disclosure Statement ("IDS") and Form PTO/SB/08 ("Form") on April 30, 2008, along with copies of the foreign and non-patent literature documents listed on its respective Form. In addition, Applicant filed an IDS and Form on April 9, 2009, along with the foreign and non-patent literature documents listed on its respective Form.

To date, the Examiner has not acknowledged either of the two IDSs and Forms indicating the documents listed therein were considered. Copies of both IDSs, Forms, Electronic Acknowledgement Receipt for the IDS filed April 30, 2008, and postcard stamped by the Patent Office indicating receipt of the IDS filed April 9, 2009, are enclosed.

The Examiner is respectfully requested to consider the IDSs and Forms and return to Applicant indicating consideration of the listed documents.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: _____

6/3/10

By: _____

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